

Electronic Acknowledgement Receipt

EFS ID:	7945248
Application Number:	10530562
International Application Number:	
Confirmation Number:	8996
Title of Invention:	PRODUCTION METHOD FOR THIN-FILM CRYSTAL WAFER, SEMICONDUCTOR DEVICE USING IT AND PRODUCTION METHOD THEREFOR
First Named Inventor/Applicant Name:	Masahiko Hata
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Filer Authorized By:	Joseph J. Ruch
Attorney Docket Number:	Q87267
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Application Type:	U.S. National Stage under 35 USC 371

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Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	\$ 180
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
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1		Q87267_IDS.pdf	193424 02b198f55bc44849324f7b7240b0c98b11ba986	yes	4
Multipart Description/PDF files in .zip description					
Document Description			Start	End	
Transmittal Letter			1	2	
Information Disclosure Statement (IDS) Filed (SB/08)			3	4	
Warnings:					
Information:					
2	NPL Documents	Q87267_Chinese_Office_Action.pdf	243490 932ee073a150034434a4e0918bc0ba28c8666	no	6
Warnings:					
Information:					
3	Foreign Reference	Q87267_JP57103351.pdf	136234 7354335d7c55942a8c3893c8997c7d2137261c7	no	4
Warnings:					
Information:					
4	Foreign Reference	Q87267_JP60015970.pdf	263903 24c0c0c098abb8f16c0d62c02c380cb1942c201	no	5
Warnings:					
Information:					
5	Foreign Reference	Q87267_JP63199460.pdf	243849 694333c7790a59553bc0b1b6c7838373c635	no	6
Warnings:					
Information:					
6	Fee Worksheet (PTO-875)	fee-info.pdf	30747 ed3ba072931a0cc250f86c0f10f68c37432f338	no	2
Warnings:					
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Total Files Size (in bytes):			1111647		

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If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.